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TBLG
11-1202IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Seutter et al. ✓

Case: 5192 USA/ISM/CORE MCVD/BG

Serial No.: 09/776,329 ✓

Filed: February 2, 2001 ✓

Group Art Unit: 2822

Examiner: Toniae M. Thomas ✓

Title: FORMATION OF A TANTALUM-NITRIDE LAYER

COMMISSIONER FOR PATENTS
Washington, DC 20231

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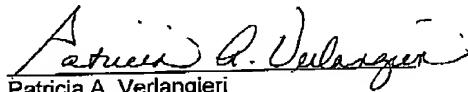
TECHNOLOGY CENTER 2800

SIR:

RESPONSE TO RESTRICTION REQUIREMENT

In response to the Office Action dated October 21, 2002 (Paper No. 4) which imposed a restriction requirement in the above-captioned patent application, the applicants hereby elect Group I (Claims 1-28 and 32-47) drawn to a coating method, classified in class 427, subclass 255.394. Additionally, the applicants reserve the right to subsequently file divisional applications in order to prosecute the inventions recited in any one or more of the non-elected claims.

Respectfully,

11/11/02
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